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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hitoshi SAOMOTO et al.**

Art Unit: **2828**

Application Number: **10/592,943**

Examiner: **Michael Carter**

Filed: **September 15, 2006**

Confirmation Number: **8662**

For: **SEMICONDUCTOR LASER ELEMENT AND MANUFACTURING METHOD
THEREOF**

Attorney Docket Number: **062998**
Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97(c)(1)/(e)(1)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 5, 2008

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO/SB/08. A copy of each non - U.S. document is attached.

This Information Disclosure Statement (IDS) is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry of the national stage for the above-captioned application, but prior to issuance of either a final official action or a Notice of Allowance.

The undersigned hereby certifies that each item of information contained in the IDS was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the IDS. A copy of the foreign communication citing the documents is attached.

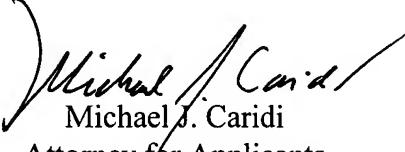
Application No.: 10/592,943
Art Unit: 2828

Information Disclosure Statement under 1.97(c)(1)
Attorney Docket No.: 062998

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Respectfully submitted,

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Enclosures: PTO/SB/08
Foreign Communication